The Research Grants Council of Hong Kong NSFC/RGC Joint Research Scheme Joint Completion Report

(Please attach a copy of the completion report submitted to the NSFC by the Mainland researcher)

Part A: The Project and Investigator(s)

1. Project Title

Single-crystalline silicon cantilever-resonator gas sensor array fabricated using silicon-migration technology for air quality monitoring

面向空氣質量監測的基於硅遷移技術單晶硅諧振懸臂梁氣體傳感器陣列

2. Investigator(s) and Academic Department/Units Involved

	Hong Kong Team	Mainland Team
Name of Principal Investigator (<i>with title</i>)	WONG Man (王文)	王曉紅 (WANG Xiaohong)
Post	Professor (教授)	教授 (Professor)
Unit / Department / Institution	ECE/HKUST	IME/Tsinghua University
Contact Information	Department of Electronic and Computer Engineering, HKUST, Clear Water Bay, Hong Kong. Tel: +852 23587057 eemwong@ust.hk	北京清華大學微電子學研究 所微納系統研究室. Tel: +86 010 62798432 wxh-ime@mail.tsinghua.edu.cn
Co-investigator(s) (with title and institution)		

3. Project Duration

	Original	Revised	Date of RGC/ Institution Approval (must be quoted)
Project Start date	Jan/1/2016		
Project Completion date	Dec/31/2019		
Duration (in month)	48		
Deadline for Submission of Completion Report	Dec/31/2020		

Part B: The Completion Report

5. Project Objectives

- 5.1 Objectives as per original application
 - *1.* Apply the silicon-migration technology to realize a micro-balance based on MEMS cantilever resonator.
 - 2. Apply gas-sensitive materials to the cantilever resonator and obtain specific gas sensitivities for major air pollutants.
 - 3. Realize an air quality monitoring system based on the micro-balance and assess its potential for commercialization.
- 5.2 Revised Objectives

Date of approval from the RGC:

Reasons for the change:

1. 2. 3.

6. Research Outcome

Major findings and research outcome (maximum 1 page; please make reference to Part C where necessary)

Unlike capacitive and piezoelectric transduction mechanisms, the thermally actuated and piezoresistively sensed resonator could extract energy from a direct-current (DC) power supply. Physics-based mathematical models of (1) the temperature distribution along an actuation beam subjected to both DC and time-varying electrical bias and (2) the piezoresistance-induced feedback mechanisms have been developed. Extracting energy from the DC component of the power supply is akin to an effective reduction in damping, hence an increase in the effective quality factor. When the effective damping becomes zero, the resonator oscillates without requiring a time-varying excitation signal. In conventional resonators, such sustained resonance requires an external feedback circuit. Applying the model, an in-plane flexural mode resonator was designed and subsequently fabricated using the silicon-migration technology. By increasing the DC bias applied to the actuation beam from 5 to 13 V, the loss due to heat dissipation and mechanical damping were partially compensated due to the aforementioned piezoresistive feedback mechanism, thus resulting in an increase in the quality factor. Such tuning of the quality factor has been demonstrated and presented in the paper by Sen Xu at the Transducers 2019 conference.

A novel high-performance graphene-based gas sensor based on the design of mosaic-like assembled monolayer of reduced graphene oxide/silver sensing membrane was demonstrated. Combining spin-coating and the self-assembly methods, the film deposition scheme was simple and highly reproducible. The good quality of the resulting film morphology contributed to the sensing performance of the sensor. Even when operated at room temperature, the sensor could fully recover to the initial state without requiring any power-consuming treatment like UV/IR irradiation or resistive heating. The response of the sensor showed good agreement with the Langmuir isotherm. This work was presented in the paper by Xinyan Jia at the Transducers 2019 conference, which was extended and subsequently published in the Journal of Microelectromechanical Systems, also in 2019.

Potential for further development of the research and the proposed course of action *(maximum half a page)*

Sensors for both particulate and gas detection could be further improved. In addition to increasing the sensitivities, gas sensing specificity needs to be investigated and characterized. Specificity refers to the ability of a sensor to distinguish different gas contaminants, such as carbon monoxide, nitrous oxide, and sulfur dioxide, etc. One possible approach is the construction of functionalized interdigitated electrodes on micro hot-plates operating at different temperatures. Metal-oxide semiconductors, such as tin (IV) oxide are commonly deployed as functional receptor materials. The deployment of different functional materials to improve specificity can also be investigated. A second development effort is the monolithic integration of particulate- and gas-sensors. Such integration generally offers better system performance and lower system cost. Silicon-migration technology is a feasible approach in resolving process incompatibility issues during monolithic integration of disparate devices.

7. The Layman's Summary

(describe <u>in layman's language</u> the nature, significance and value of the research project, in no more than 200 words)

Sensing of contaminants is an important endeavor for air-quality assessment in open environments, factories and homes. Contaminants are generally classified as particulates and gases, both are harmful when present in excess. Micro-sensors for both have been developed in this project, with a thermomechanical resonator for particulate sensing and interdigitated electrodes functionalized with reduced graphene oxide for gas sensing. Encouraging preliminary performance have been obtained. Improvement and deployment of the sensors developed in the present work will be beneficial to air-quality assessment.

Part C: Research Output

8. Peer-reviewed journal publication(s) arising <u>directly</u> from this research project

(Please attach a copy of each publication and/or the letter of acceptance if not yet submitted in the previous progress report(s). All listed publications must acknowledge RGC's funding support by quoting the specific grant reference.)

The	The Latest Status of Publications		Author(s)	Title and	Submitted to	Attached	Acknowledge	Accessible	
Year of	Year of	Under	Under	(bold the	Journal/	RGC	to this	d the support	from the
publication	Acceptance	Review	Preparation	authors	Book	(indicate the	report (Yes	of this Joint	institutional
-	(For paper		-	belonging to	(with the	year ending			repository
	accepted but		(optional)	the project	volume,	of the		Scheme	(Yes or No)
	not yet			teams and	pages and	relevant		(Yes or No)	
	published)			denote the	other	progress			
	1 ,			corresponding	necessary	report)			
				author with an	publishing				
				asterisk*)	details				
					specified)				
2019				Xinyan Jia,	Mosaic-Like	2020	Yes	Yes (Please	No
				Xiaohong	Micropatter			note the	
				Wang*	ned			equivalent	
J1					Monolayer			project code	
					RGO/AgNP			for the	
					s Film Gas			Tsinghua	
					Sensor With			partner is	
					Enhanced			6153116600	
					Room-Temp			6)	
					erature NO2				
					Response/R				
					ecovery				
					Properties				
					JOURNAL				
					OF				
					MICROELE				
					CTROMEC				
					HANICAL				
					SYSTEMS,				
					28(5):				
					833~840				

9. Recognized international conference(s) in which paper(s) related to this research project was/were delivered (*Please attach a copy of each delivered paper. All listed papers must acknowledge RGC's funding support by quoting the specific grant reference.*)

Month/Year/	Title	Conference Name	Submitted	Attached	Acknowledged	Accessible
Place			to RGC	to this	the support of	from the
			(indicate the			institutional
			year ending	(Yes or No)	Research	repository
			of the		Scheme	(Yes or No)
			relevant		(Yes or No)	
			progress			
T (2010)	TT1 1		report)	* 7	¥7 (D1	* 7
Jun/2019/	Thermal	2019 20th	2020	Yes	Yes (Please	Yes
Germany	Piezoresistive	International			note the	
	Q-Tuning of	Conference on			equivalent	
C1	P-Type Silicon	Solid-State Sensors,			project code	
	Resonator with	Actuators and			for the	
	Feedthrough	Microsystems &			Tsinghua	
	Reduction	Eurosensors XXXIII			partner is	
					61531166006)	

Jun/2019/	Mosaic-Like	2019 20th	2020	Yes	Yes (Please	No
Germany	Monolayer	International			note the	
	RGO/Ag Film	Conference on			equivalent	
	via Ultrafast	Solid-State Sensors,			project code	
C2	Two-dimensional	Actuators and			for the	
	Assembly for	Microsystems &			Tsinghua	
	High	Eurosensors XXXIII			partner is	
	Performance				61531166006)	
	Room-					
	Temperature Gas					
	Sensor					
Jan/2018/	A Novel	2018 IEEE Micro	2020	Yes	Yes (Please	No
United	Potential	Electro Mechanical			note the	
Kingdom	Modulated	Systems (MEMS)			equivalent	
	Amino Acid				project code	
	Sensing Chip				for the	
	Modified by				Tsinghua	
C3	MXENE for				partner is	
	Total				61531166006)	
	Internal					
	Reflection					
	Imaging					
	Ellipsometry					
	Biosensor					

10. Student(s) trained (*Please attach a copy of the title page of the thesis.*)

Name	Degree registered for	Date of registration	Date of thesis
			submission/
			graduation
Sen XU	PhD (Switched to	2016	Jun/2020
	MPhil)		
Yushen Hu	PhD	2018	Jun/2022

S1

S2

11. Other impact (e.g. award of patents or prizes, collaboration with other research *institutions, technology transfer, etc.*)

Patent application:

單片集成的有源矩陣微熱板及其製造方法.

一種低阻抗電極的製備方法及低阻抗電極.

複合電極材料及其用途.

12. Statistics on Research Outputs (*Please ensure the summary statistics below are consistent with the information presented in other parts of this report.*)

	Peer-reviewed journal publications	Conference papers	Scholarly books, monographs and chapters	Patents awarded	Other research outputs (Please specify)
No. of outputs arising directly from this research project [or conference]	1	3	0	0	0